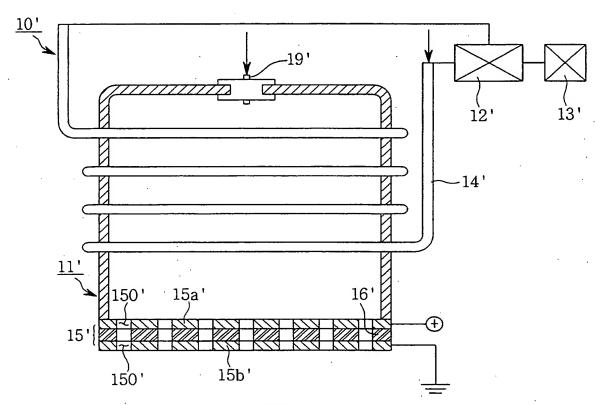
REPLACEMENT SHEET
Inventor: YEOM et al.
Atty Dkt. No.: 061887-0119
Application No. 10/814,148

3-GRID NEUTRAL BEAM SOURCE USED FOR ETCHING SEMICONDUCTOR DEVICE
Page 1 of 2



FIG. 1



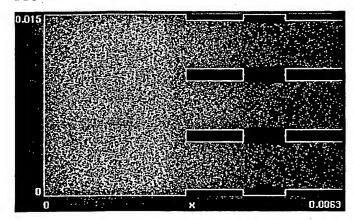
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REPLACEMENT SHEET Inventor: YEOM et al.

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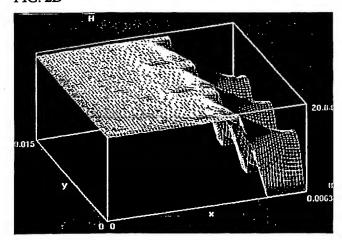
Page 2 of 2

FIG. 2A



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FIG. 2B



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